Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/685,940	RENTSCHLER ET AL.	
Examiner	Art Unit	
Hona C. Kim	2185	

	SEARCHED					
Class	Subclass	Date	Examiner			
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	154					
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365	233					
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327	121	8				
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INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
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EAST	6/12/06	W		